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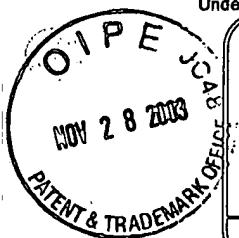
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PTO/SB/08B (10-96)

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Substitute for form 1449B/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet 2 of 2

Complete If Known

Application Number	09/649,569
Filing Date	AUGUST 28, 2000
First Named Inventor	PATEL et al.
Group Art Unit	1746
Examiner Name	Unknown
Attorney Docket Number	P06-US

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

Examiner Initials ¹	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	EA	STRELLER et al., "Selectivity in Dry Etching of Si(100) and XeF ₂ and VUV Light", Elsevier Science B.V., Applied Surface Science, (1996), 106: pp. 341-346	
	EB	VUGTS et al., "Si/XeF ₂ Etching: Temperature Dependence", J. Vac. Sci. Technol. A 14(5), (Sep/Oct 1996), pp. 2766-2774	
	EC	WANG et al., "Gas-Phase Silicon Etching with Bromine Trifluoride", Transducers '97, 1997 International Conference on Solid-State Sensors and Actuators, Chicago (June 16-19), pp. 1505-1508	
	ED	WINTERS, H.F., "Etch Products from the Reaction of XeF ₂ with SiO ₂ , SiO ₃ , Si ₃ N ₄ , SiC, and Si in the Presence of Ion Bombardment", J. Vac. Science Technology B 1(4), (Oct-Dec 1983), pp. 927-931	
	EE	WINTERS et al., "The Etching of Silicon with XeF ₂ Vapor", Appl. Phys. Lett. 34(1), January 1, 1979, pp. 70-73.	
	EF	GILDEMEISTER, J.M., "Xenon Difluoride Etching System", (Nov 17, 1997)	
	EG	"Xenon Difluoride Isotropic Etch System", Seeing is Believing, Surface Technology Systems Ltd. brochure, Newport, UK (date unknown)	
	EH	Assorted promotional literature, Surface Technology Systems Ltd., Newport, UK (July 28, 1999)	

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Signatur

Date
Considered

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09/649,569

AUGUST 28, 2000

PATEL et al.

1746

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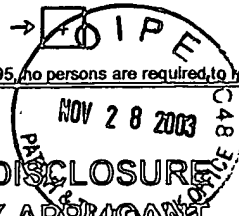
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Substitute for form 1449B/PTO			Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)			Application Number	09/649,569
			Filing Date	AUGUST 28, 2000
			First Named Inventor	PATEL et al.
			Group Art Unit	1746
			Examiner Name	Unknown
			Attorney Docket Number	P06-US
Sheet	2	of	2	

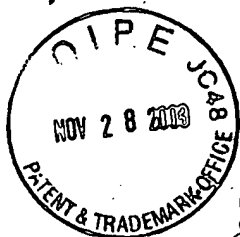
OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS			
Examiner Initials ¹	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	BA	ALIEV et al., "Development of Si(100) Surface Roughness at the Initial Stage of Etching in F2 and XeF2 Gases Ellipsometric Study", Surface Science 442 (1999), pp. 206-214.	
	BB	HABUKA et al., "Dominant Overall Chemical Reaction in a Chlorine Trifluoride-Silicon-Nitrogen System at Atmospheric Pressure", Japan Journal of Applied Physics Vol 38 (1999), pp. 6466-6469.	
	BC	HECHT et al., "A Novel X-ray Photoelectron Spectroscopy Study of the Al/SiO2 Interface", J. Appl. Phys. 57 (1: 15 June 1985, pp. 5256-5261.	
	BD	HOULE, F.A., "Dynamics of SiF4 Desorption During Etching of Silicon by XeF2", IBM Almaden Research Center, 15 April 1987, pp. 1866-1872.	
	BE	FLAMM et al., "XeF2 and F-Atom Reactions with Si: Their Significance for Plasma Etching", Solid State Technol. 26, 117 (1983).	
	BF	IBBOTSON et al., "Plasmaless Dry Etching of Silicon with Fluorine-containing Compounds", Journal of Applied Physics, vol. 56, no. 10, Nov. 1984, pp. 2939-2942.	
	BG	IBBOTSON et al., "Comparison of XeF2 and F-atom Reactions with Si and SiO2", Applied Physics Letter, vol. 44, 1129 (1984).	
	BH	WINTERS et al., "The Etching of Silicon with XeF2 Vapor", Applied Physics Letters, vol. 34, no. 1, 1979 pp. 70-73.	
	BI	XACTIX, Inc., Marketing Brochure, June 27, 1999	
	BJ	WANG et al., "Gas-Phase Silicon Etching with Bromine Trifluoride", TRANSDUCERS '97, International Conference on Solid-State Sensor and Actuators, Chicago, June 16-19, 1997, pp. 1505-1508.	

Examiner Signature		Date Considered	
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		Application Number	09/649,569
		Filing Date	AUGUST 28, 2000
		First Named Inventor	PATEL et al.
		Art Unit	1746
		Examiner Name	PURNELL, A.
		Attorney Docket Number	P06-US
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U.S. PATENT DOCUMENTS						
Examiner Initials ¹	Cite No. ¹	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)				
	FA	US-	3,511,727	05-12-1970	Hays, R.G.	
	FB	US-	4,695,700	09-22-1987	Provence et al.	
	FC	US-	4,749,440	08-07-1988	Blackwood et al.	
	FD	US-	5,208,471	04-27-1993	Smith, D.K.	
	FE	US-	5,439,553	08-08-1995	Grant et al.	
	FF	US-	5,534,107	07-09-1998	Gray et al.	
	FG	US-	5,718,495	02-10-1998	Butterbaugh et al.	
	FH	US-	5,728,480	03-10-1998	Pister, K.S.	
	FI	US-	5,757,458	05-26-1998	Yamazaki et al.	
	FJ	US-	5,858,065	01-12-1999	U et al.	
	FK	US-	6,022,456	02-08-2000	Manning, T.J.	
	FL	US-	6,162,367	12-19-2000	Tai et al.	
	FM	US-	6,277,173 B1	08-21-2001	Sadakata et al.	
	FN	US-	6,290,864 B1	09-18-2001	Patel et al.	
	FO	US-	6,328,801 B1	12-11-2001	Gary et al.	
	FP	US-	6,334,928 B1	01-01-2002	Sekine et al.	
	FQ	US-	6,355,181 B1	03-12-2002	McQuarrie, A.D.	
	FR	US-	2001/0002663 A1	06-07-2001	Tai et al.	
	FS	US-	2002/0033229 A1	03-21-2002	Leboulitz et al.	
		US-				

FOREIGN PATENT DOCUMENTS							
Examiner Initials ¹	Cite No. ¹	Foreign Patent Document		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³	Number ⁴ - Kind Code ⁵ (if known)				
	GA	EP	0704884-A2	04-03-1998	Mehta, J.		
	GB	EP	0878824-A2	11-18-1998	McQuarrie et al.		
	GC	EP	0878824-A3	01-19-2000	McQuarrie et al.		
	GD	EP	0955688-A2	11-10-1999	Yao et al.		
	GE	JP	1982/57098879-A	06-18-1982	Tsunetoshi, A.		
	GF	JP	1983/58130529-A	08-04-1983	Yoshihiro et al.		
	GG	JP	1985/60057938-A	04-03-1985	Katsumi et al.		
	GH	JP	1988/61053732-A	03-17-1988	Arala et al.		
	GI	JP	1988/61134019-A	06-21-1986	Shinji et al.		
	GJ	JP	1988/61181131-A	08-13-1988	Shinji et al.		

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Art Unit	1746
Examiner Name	PURNELL, A.
Attorney Docket Number	P06-US

(use as many sheets as necessary)

Sheet 2 of 3

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		Country Code ³ -Number ⁴ - Kind Code ⁶ (if known)				
	GK	JP-1986/61187238-A	08-20-1986	Nobuo et al.		
	GL	JP-1986/61270830-A	12-01-1986	Toru. T.		
	GM	JP-1987/62071217-A	04-01-1987	Toru et al.		
	GN	JP-1988/63155713-A	06-28-1988	Tadashi, F.		
	GO	JP-1989/01208834-A	08-22-1989	Nobuo et al.		
	GP	JP-1989/01217921-A	08-31-1989	Tsuneo et al.		
	GQ	JP-1990/02250323-A	10-08-1990	Susumu et al.		
	GR	JP-1991/03012921-A	01-21-1991	Nobuo et al.		
	GS	JP-1992/04096222-A	03-27-1992	Atsuyuki, A.		
	GT	JP-1995/07029823-A	01-31-1995	Hiroshi, T.		

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